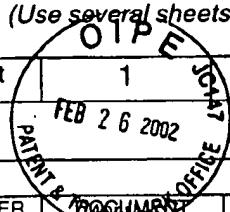


Subt. For, PTO-1449		Docket Number 109635.150	Application Number 10/004,565
INFORMATION DISCLOSURE IN AN APPLICATION (Use several sheets if necessary)		Applicant Albert Perdon	
		Filing Date December 5, 2001	Group Art Unit 2614
Sheet	1	OF	1




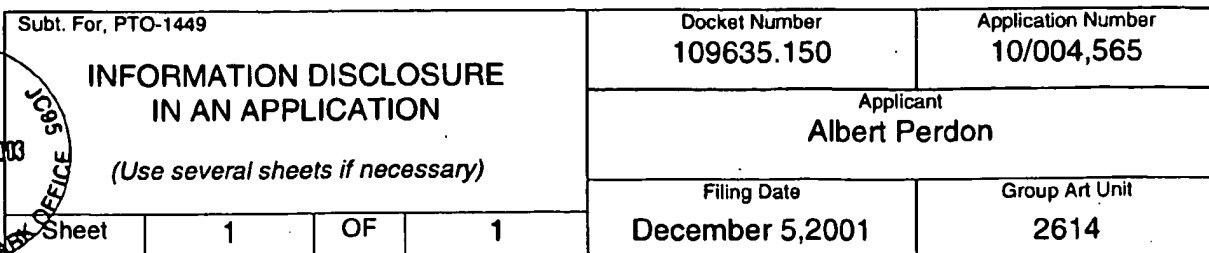
U.S. Patent Documents						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TRN	6,163,316	12/19/00	Killian			
	6,177,931	01/23/01	Alexander et al			
	6,018,372	01/25/00	Etheredge			
	6,305,017	10/16/01	Satterfield			
	5,592,551	01/07/97	Left et al.			
	6,014,654	01/11/00	Ariyoshi			
	6,041,311	03/21/00	Chislenko et al.			
	6,049,777	04/11/00	Sheena et al.			
	6,064,980	05/16/00	Jacobi et al.			
	6,092,049	07/18/00	Chislenko et al.			
	6,119,101	09/12/00	Peckover			
	6,134,532	10/17/00	Lazarus et al.			
	6,026,368	02/15/00	Brown et al.			
	6,157,946	12/05/00	Itakura et al.			
	5,347,632	09/13/94	Filepp et al.			
	5,572,643	11/05/96	Judson			
	5,740,549	04/14/98	Reilly et al.			
	5,754,774	05/19/98	Bittinger et al.			
	5,761,662	06/02/98	Dasan			
	5,794,210	08/11/98	Goldhaber et al.			
	5,812,784	09/22/98	Watson et al.			
	5,913,040	06/15/99	Rakavy et al.			
	5,946,646	08/31/99	Schena et al.			
	5,959,623	09/28/99	Van Hoff et al.			

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Foreign Patent Documents						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	WO 00/49801	24.08.2000	WIPO			

Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)	
	U.S. Patent Application Publication No. 20010049620

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Foreign Patent Documents							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)		
		U.S. Patent Application Publication No. 2002/0049972, Apr. 25, 2002, Kimoto
EXAMINER		DATE CONSIDERED 2/5/08
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.		